

BAU 1762



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<b>TRANSMITTAL FORM</b> <i>(to be used for all correspondence after initial filing)</i>	<b>Application Number</b>	09/854,092	
	<b>Filing Date</b>	May 10, 2001	
	<b>First Named Inventor</b>	Quang, T. P.	
	<b>Group Art Unit</b>	1762	
	<b>Examiner Name</b>	Unknown	
<b>Total Number of Pages in This Submission</b>	5	<b>Attorney Docket Number</b>	PA1663US

ENCLOSURES (check all that apply)		
<input type="checkbox"/> Fee Transmittal Form	<input type="checkbox"/> Assignment Papers (for an Application)	<input type="checkbox"/> After Allowance Communication to Group
<input type="checkbox"/> Fee Attached	<input type="checkbox"/> Drawing(s)	<input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences
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<input type="checkbox"/> Affidavits/declaration(s)	<input type="checkbox"/> Petition to Convert to a Provisional Application	<input type="checkbox"/> Status Letter
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<input type="checkbox"/> Certified Copy of Priority Document(s)	<input type="checkbox"/> CD, Number of CD(s) _____	3. Statement of Co-Pending Applications (2x)
<input type="checkbox"/> Response to Missing Parts/Incomplete Application	<b>Remarks</b>	
<input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	Total page number does not include postcard or copies of co-pending applications.	

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT	
Firm or Individual name	Carr & Ferrell, LLP Cust. No. 22830
Signature	 Reg. No. 47,059
Date	August 6, 2001

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IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Tony P. Chiang and Karl F. Leeser  
SERIAL NO.: 09/854,092  
FILED: May 10, 2001  
TITLE: Method and Apparatus for Improved Temperature Control  
in Atomic Layer Deposition  
EXAMINER: Unknown  
GROUP ART UNIT: 1762  
ATTY.DKT.NO.: PA1663US

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INFORMATION DISCLOSURE STATEMENT  
Under 37 C.F.R. §§ 1.56, and 1.97-1.98

SIR:

Pursuant to the provisions of 37 C.F.R. §§ 1.56 and 1.97-98 of the Rules of Practice in Patent Cases, enclosed herewith is a list of co-pending patent applications that may be directed towards similar subject matter. The Examiner is requested to make these references of official record in the application. The references cited may be material to examination of the application and are submitted in compliance with Applicant(s)'s duty of disclosure as defined by 37 C.F.R. § 1.56.



No representation is made or intended as to the completeness of this list, nor is the inclusion of any reference on this list an admission that it is prior art or pertinent to this application.

Respectfully submitted,

Tony P. Chiang, et al.

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Dated: August 6, 2001

By: 

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**List of Co-Pending Patent Applications That  
May Be Directed Towards Similar Subject Matter**

Examiner's Initials	Serial Number	First-Named Inventor	Title	Filing Date
	09/812,285	Tony P. Chiang	A Sequential Method for Depositing a Film by Modulated Ion-Induced Atomic Layer Deposition (MII-ALD)	03-19-01
	09/812,352	Tony P. Chiang	System and Method for Modulated Ion-Induced Atomic Layer Deposition (MII-ALD)	03-19-01
	09/812,486	Tony P. Chiang	A Continuous Method for Depositing a Film by Modulated Ion-Induced Atomic Layer Deposition (MII-ALD)	03-19-01
Examiner's Signature:				Date